

<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT PTO-1449</b>	Docket No. <b>52433/783</b>	Application No. <b>10/518,664</b>
	Applicant(s) <b>Akira Usami et al.</b>	Examiner <b>Deborah YEE</b>
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		Art Unit <b>1793</b>

## **U. S. PATENT DOCUMENTS**

## **FOREIGN PATENT DOCUMENTS**

EXAMINER INITIAL	DOCUMENT NUMBER	DATE mm/dd/yyyy	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						Yes	No
	2001-214236	08/07/2001	JP			Abstract	
	2001-123243	05/08/2001	JP			Abstract	
	01-149923	06/13/1989	JP			Abstract	
	2000-017381	01/18/2000	JP			Abstract	
	52-011118	01/27/1977	JP			Abstract	

## **OTHER DOCUMENTS**

EXAMINER INITIAL	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.
	Japanese Office Action dated October 21, 2008 issued in corresponding Japanese Application No. 2003-138374.

**EXAMINER** \_\_\_\_\_ **DATE CONSIDERED** \_\_\_\_\_  
**EXAMINER:** Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.